



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
Group Art Unit 2624

EPW

In re

Patent Application of

Patrick James Noffke, et al.

Application No. 10/790,451

Confirmation No.: 9929

Filed: February 17, 2004

Examiner: Park, Edward

“SYSTEM AND METHOD FOR
MEASURING COLOR ON A PRINTING
PRESS”

INFORMATION REGARDING RELATED APPLICATION

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Applicants wish to direct the Examiner's attention to U.S. Application Serial No. 10/424,230, which is a parent application of the present case. This case is assigned to Art Unit 2624 and is being examined by Anand P. Bhatnagar. The subject matter of the parent application may be related to the subject matter of the present CIP Application.

Respectfully submitted,

Thomas J. Otterlee
Reg. No. 48,652

File No. 077077-9159-01
Michael Best & Friedrich LLP
100 East Wisconsin Avenue
Suite 3300
Milwaukee, Wisconsin 53202-4108
262-956-6523